

Notice of References Cited	Application/Control No. 10/622,917	Applicant(s)/Patent Under Reexamination DOBBS ET AL.
	Examiner Chen-Wen Jiang	Art Unit 3744

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	C	US-6,128,188 A	10-2000	Hanners, John C.	361/694
	D	US-6,412,292 B2	07-2002	Spinazzola et al.	62/89
	E	US-6,487,074 B1	11-2002	Kimura et al.	361/695
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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